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		Application Number	10/553,326		
		Filing Date	October 14, 2005		
		First Named Inventor	Liang-Chy Ghien		
		Art Unit	2871		
		Examiner Name	Tai V. Duong		
Sheet	1	of	1	Attorney Docket Number	KENT-B-PCT-US

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
/T.D./		O. Yaroshchuk, Yu. Zakrevskyy, A. Dobrovolskyy, S. Pavlov, <i>Liquid Crystal Alignment on the Polymer Substrates Irradiated by Plasma Beam. Proc. of SPIE</i> , Vol. 4418, 49-53 (2001). No month provided.	X
/T.D./		O. Yaroshchuk, Yu. Zakrevskyy, A. Dobrovolskyy, S. Pavlov, <i>Polymer Films Treated with Plasma Beam as Aligning Substrates for Liquid Crystals</i> , Asia Display/IDW, 73-76 (2001). No month provided.	X
/T.D./		O. Yaroshchuk, R. Kravchuk, A. Dobrovolskyy, S. Pavlov, <i>P-14: Plasma Treatment as a Method of In-Plane LC Alignment</i> , Eurodisplay, 421-424 (2002). No month provided.	X

Examiner Signature	/Tai Duong/	Date Considered	11/21/2009
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